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Optical absorption in highly-strained Ge/SiGe quantum wells: the role of $\Gamma \rightarrow \Delta$ scattering

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We report the observation of the quantum-confined Stark effect in Ge/SiGe multiple quantum well heterostructures grown on Si$_{0.22}$Ge$_{0.78}$ virtual substrates. The large compressive strain in the Ge quantum well layers caused by the lattice mismatch with the virtual substrate results in a blue shift of the direct absorption edge, as well as a reduction in the $\Gamma$-valley scattering lifetime because of strain-induced splittings of the conduction band valleys. We investigate theoretically the $\Gamma$-valley carrier lifetimes by evaluating the $\Gamma \rightarrow L$ and $\Gamma \rightarrow \Delta$ scattering rates in strained Ge/SiGe semiconductor heterostructures. These scattering rates are used to determine the lifetime broadening of excitonic peaks and the indirect absorption in simulated absorption spectra, which are compared with measured absorption spectra for quantum well structures with systematically-varied dimensions. We find that $\Gamma \rightarrow \Delta$ scattering is significant in compressively strained Ge quantum wells and that the $\Gamma$-valley electron lifetime is less than 50 fs in the highly-strained structures reported here, where $\Gamma \rightarrow \Delta$ scattering accounted for approximately half of the total scattering rate.

I. INTRODUCTION

The optical properties of direct band gap semiconductor quantum wells have been studied extensively over the past few decades, and semiconductor quantum well heterostructures are found in a number of commercial optoelectronic devices, including lasers and optical modulators. Recently, the optoelectronic properties of Ge/SiGe quantum well structures grown on silicon substrates have become the subject of growing research interest. The quantum-confined Stark effect (QCSE) was first reported in this system in 2005, where a multiple quantum well (MQW) structure was grown on an alloy virtual substrate, within which strain relaxes via the insertion of misfit dislocations and the virtual substrate composition was chosen to provide strain balance to the MQW layers so that no net strain accumulates in the MQW stack. In the following years the QCSE has been reported using a variety of quantum well dimensions and virtual substrate compositions, and has been extended to configurations for modulator structures, as well as to investigations of the carrier dynamics and to photoluminescence studies.

In III-V quantum well systems the $\Gamma$-valley electron lifetimes are relatively long (>$1$ ps), and consequently the exciton lineshapes can be described by a Gaussian profile. In Ge/SiGe quantum wells however, $\Gamma$-valley electrons are able to scatter into the lower-lying indirect valleys, and this results in a reduction of the electron lifetimes. The scattering lifetime is significant, as it determines the strength of the indirect absorption as well as the amount of lifetime broadening of the excitonic peaks. Two of the most important metrics of an optical modulator are the insertion loss and extinction ratio that can be achieved. The scattering lifetime becomes a fundamental limiting factor for the insertion loss of a Ge/SiGe quantum well modulator because these broadening mechanisms introduce losses in the structure at the applied field which corresponds to the transmitting state of the modulator. This in turn affects the extinction ratio, since in the design of a practical device there is a trade-off between the extinction ratio and the insertion loss that can be tolerated.

Typically, contrast in the absorption coefficient that has been achieved with Ge/SiGe quantum wells has been at wavelengths around 1450 nm, however, most telecommunications applications use wavelengths close to 1550 nm. In some recent work, the absorption coefficient contrast at 1550 nm has remained fairly constant, but this has required elevated temperatures to exploit the temperature-induced bandwidth narrowing. Recently, operation at 1310 nm has been reported by exploiting compressive in-plane strain to induce a blue-shift of the direct band edge, however, it remains unclear what the impact of the strain is on the carrier dynamics, and hence on the indirect absorption and lifetime broadening of excitonic peaks. In this work, strain-balanced Ge/Si$_{0.4}$Ge$_{0.6}$ multiple quantum well stacks were epitaxially grown on Si$_{0.22}$Ge$_{0.78}$ virtual substrates on (100) silicon wafers in order to investigate the absorption properties of Ge quantum wells with large amounts of compressive in-plane strain. The measured absorption spectra are compared with simulated data for 7, 8, 9 and 14-nm-
thick quantum well heterostructures to gain insight into the physics of the system. We find that there is considerable splitting of the $\Delta$-valley conduction band edges, and scattering into four of the six strain-split $\Delta$-valley states is energetically allowed. This results in a reduction of the $\Gamma$-valley lifetime compared with bulk unstrained Ge (and with Ge quantum wells grown on SiGe virtual substrates with a smaller Si fraction), and is manifest in the spectra as an increased lifetime broadening component of the excitonic peaks, as well as an increase in the indirect absorption. We study the excitonic broadening as a function of the applied electric field, allowing separation of the contributions due to lifetime broadening, which is attributed to phonon scattering, and to disorder broadening caused by fluctuations in the dimensions of the quantum wells throughout the structure.

II. ABSORPTION SPECTRA FOR HIGHLY-STRAINED MQW STRUCTURES

Strained-balanced Ge/Si$_{0.4}$Ge$_{0.6}$ multiple-quantum-well (MQW) heterostructures with ten wells and eleven barriers were grown at 450°C using reduced-pressure chemical vapour deposition (RP-CVD) on a relaxed Si$_{0.22}$Ge$_{0.78}$ virtual substrate, which was formed using a reverse linear grading technique. The bottom layer of the device was p-doped with boron at $1 \times 10^{19}$ cm$^{-3}$, on which was grown a 100-nm-thick intrinsic SiGe spacer, the MQW layers, a second 100-nm-thick intrinsic spacer layer, an n-type SiGe layer doped with phosphorous at $1 \times 10^{19}$ cm$^{-3}$, and finally a 2-nm-thick Si cap layer. 80-µm-diameter circular mesas were etched to form vertical $p-i-n$ diodes, and a Ti/Al metal stack was deposited and sintered at 400°C for 30 minutes to form electrical contacts.

A 100-W xenon lamp was used as a light source, and a 3-mm-bandwidth monochromator was used to provide wavelength selectivity. The signal was optically-chopped and focussed onto an optical fibre to illuminate the reverse-biased diodes. Lock-in detection was used to improve the signal-to-noise ratio, allowing the absorption spectra to be inferred from the wavelength-dependent photocurrent measured in the devices.

The photocurrent spectra for the 7, 8, 9 and 14-nm-wide quantum well structures are shown in Figs. 1(a–d). As expected, there was a systematic blue shift in the absorption edge as the width of the quantum wells is decreased. The Stark shift at a given applied bias was also larger for the wider quantum wells, as was the reduction in the magnitude of the $\hbar\omega_{\Gamma}$ exciton peak that occurs at the absorption edge when a given bias is applied, which results from the larger spatial separation of the electron and hole wavefunctions.

When the dimensions of the quantum wells were decreased, the amount of excitonic broadening increased, as did the amount of indirect absorption (at a given energy from the direct absorption edge). This suggests that the increased confinement energy of the $\Gamma$-valley electrons results in a decrease in the $\Gamma$-valley electron lifetime in the quantum well system. In the following section we describe the energy dependence of the $\Gamma \rightarrow L$ and $\Gamma \rightarrow \Delta$ scattering lifetimes, and go on to relate this to observable features in the absorption spectra, resulting in the simulated spectra that are shown by the dashed curves in Fig. 1.

III. $\Gamma$-VALLEY LIFETIME CALCULATION

The bandstructure of the strained heterostructure system was calculated using model solid theory with the parameters given in Table II in the appendix using the method described in Ref. 16. All calculations were performed assuming room temperature conditions of 300 K. The energy gaps between the highest of the strain-split valence band edges and the different conduction band valleys for epitaxially-grown strained Ge are plotted in Fig. 2 as a function of the composition of the virtual substrate composition. There is a considerable splitting between the in-plane ($\Delta_4$) and the growth axis ($\Delta_2$) $\Delta$-valley states with increasing in-plane compressive strain, as well as an increase in the $\Gamma$-valley band gap. This means that scattering from the $\Gamma$-valley conduction band states into the $\Delta_4$-valleys is allowed for bulk germanium epitaxially grown on a virtual substrate with a Ge fraction of around 90% or less. For the Ge/Si$_{0.4}$Ge$_{0.6}$ quantum wells on a Si$_{0.22}$Ge$_{0.78}$ virtual substrate, we find a $\Gamma$-valley conduction band offset of 985 meV, and heavy- and light-hole band offsets of 306 meV and 161 meV, respectively.

We used an effective mass model to calculate the confined state electron wavefunctions with box boundary conditions to contain the Ge/SiGe finite quantum well structure. Intervalley phonon scattering rates from the $\Gamma$-valley into the $L$ and $\Delta$ conduction band valleys were evaluated using a zeroth order deformation potential approach using the longitudinal acoustic and optical phonon scattering parameters given in Ref. 21. In order to determine the significance of quantum confinement of the electronic states on the scattering rates we compare two approaches: one whereby we treat the initial and final states as subbands, with the variation along the growth-axis described by the confined state wavefunctions of the system, and one where we use the expressions for deformation potential scattering in bulk Ge.

In the intersubband approach, the $\Gamma \rightarrow L$ scattering rates were determined from

$$W_{\Gamma \rightarrow L, \Delta} = \frac{2\pi \hbar D_{\Gamma \rightarrow L, \Delta}^2 N_{0,\text{val}}}{\hbar^2} \left( N_0 + \frac{1}{2} \pm \frac{1}{2} \right) \times \rho_v \left( E_f^v \mp \hbar \omega_{\Gamma,\Delta} \right),$$

where the subscript $v$ refers to the destination valley (i.e.,
FIG. 1. The measured photocurrent spectra for the quantum well systems. (a) 7 nm wells with 5 nm barriers, (b) 8 nm wells with 6 nm barriers, (c) 9 nm wells with 7 nm barriers and (d) 14 nm wells with 11 nm barriers. At zero applied bias, the primary absorption edge at wavelengths of approximately (a) 1160 nm, (b) 1200 nm, (c) 1240 nm, and (d) 1350 nm corresponds to the \( h_1-\Gamma_1 \) excitons in the four structures; the features at approximately 1080 nm, 1125 nm, 1150 nm and 1240 nm correspond to the \( l_1-\Gamma_1 \) excitons. Simulated data at zero bias and at the largest measured bias are shown by the dashed lines, and the magnitude of the simulated data is indicated on the right-hand side axis. Note that the measured data in (c) is the same as that reported in Ref. 5.

In the continuum approach the scattering rates were calculated using the following relation, which describes the \( \Gamma \)-valley scattering rates in a bulk semiconductor:

\[
W_{\Gamma \rightarrow L, \Delta} = \frac{2\pi \hbar D_{\Gamma V}^2 N_{\text{val}}}{2\rho \omega_{\Gamma V}} \left( N_0 + \frac{1}{2} \pm \frac{1}{2} \right) \times \rho_v(E_k \mp \hbar \omega_{\Gamma V}),
\]

(2)

where \( E_k \) is the final-state kinetic energy of the destination valley for a given scattering process. Note that here \( \rho_v \) is the 3D density of states in the destination valleys.

In both approaches the \( \Gamma \)-valley inverse scattering lifetime was found by summing the three different rates, i.e.,

\[
\frac{1}{\tau_{\Gamma}} = W_{\Gamma \rightarrow L} + W_{\Gamma \rightarrow \Delta_2} + W_{\Gamma \rightarrow \Delta_4}.
\]

(3)

Figure 3 shows the scattering rates obtained using both models. The effects of quantum confinement are reflected in the scattering rates, with the step-like features that result from the quantum-confined density of...
residual tensile strain we have included, for intervalley scattering into FIG. 3. The inverse Γ-valley scattering lifetime components FIG. 2. The energy of the conduction band valleys of epi-

g is highest. energy and when there is tensile strain the light-hole band edge is highest. Ge quantum well with Si quantum-confined at 100 kV/cm. The system is a 14-nm-thick ted curves are the scattering rates calculated according to the continuum scattering model. Also shown in the dot-

counts are the rates calculated according to the quantum-confined at zero field and the dashed curves show the rates calculated according to the quantum-confined Ge quantum well with Si virtual substrate, and the energy of the Γ-subband is indicated for reference.

states of the destination subbands. At zero field the onset of phonon absorption into the first L-valley subband is seen at 641 meV and phonon emission scattering into this subband at 696 meV. With an applied field these features occur energies approximately 10 meV smaller, reflecting the Stark shift of the L-valley confined-state wavefunc-
tions. The small step at 687 meV results from the onset of phonon absorption into the second L-valley subband. At energies larger than ~750 meV the quantum-confined nature of the scattering rates is no longer apparent, as multiple destination subbands are energetically allowed for the scattering processes. There is good agreement between the two models in terms of the overall magnitude of the rates (less than 10% deviation across a range of quantum well dimensions and substrate alloy fractions); the principal difference results from the density of final states, whilst the details of the wavefunctions themselves, as well as the overlap between them, appear to be unimportant. Therefore, due to the relative simplicity of implementing equation 2, we choose to use the continuum method for the subsequent investigation of the Γ-valley scattering lifetime.

We model indirect absorption according to the method described in Ref. 22, so that we have

$$\alpha_{\text{in}}(\omega) = C_0 S_{2D} \frac{2}{L} \frac{1}{2\pi} \frac{\hbar}{2} \int \frac{1}{(E_0 - \hbar \omega)^2} \tau_{\Gamma} \, dk_x \, dk_y, \quad (4)$$

where $S_{2D}$ is the Coulomb enhancement factor, $L$ is the periodicity of the MQW system (i.e., the well width plus the barrier width). The term $\frac{1}{(E_0 - \hbar \omega)^2}$ is the momentum matrix element between the Γ-valley electron and hole wavefunctions, which was evaluated using the formalism in Ref. 23; at the Brillouin zone centre, the reduces to

$$\frac{1}{(E_0 - \hbar \omega)^2} = E_p m_0 \left( \int \psi_\Gamma \psi_h^* \, dz \right)^2, \quad (5)$$

where $E_p = 26.3$ eV is the optical transition matrix element for germanium and $m_0$ is the electron rest mass. (Away from the zone centre the expression becomes more complex as the hole wavefunctions are given by a linear combination of light-hole, heavy-hole, and spin-orbit split-off basis states.) The terms $k_x$ and $k_y$ are the wavevectors in the growth plane, the factor of two accounts for spin degeneracy, and $C_0$ is given by

$$C_0 = \frac{\pi e^2}{N_r c \epsilon_0 \omega^2}, \quad (6)$$

where $\omega$ is the angular frequency of the light and $N_r$ is the real part of the refractive index of the material. The term $E - \hbar \omega$ is the shortfall between the photon energy and the energy of the intermediate Γ-valley state, and $\tau_\Gamma$ is the lifetime of the intermediate Γ-valley state at that energy, i.e., the energy corresponding to the absorption of light with a photon energy smaller than the direct absorption edge. It is for this reason that we determine the intervalley scattering rates as a function of the energy of the Γ-valley state relative to the top of the valence band for both the confined and continuum methods, i.e., for a range of energies including those smaller than the Γ-valley band gap.
The excitonic contribution to the spectra from each pair of electron and hole subbands was modelled according to

$$\alpha_{ex} = \frac{2C_0}{L} \left| \langle \psi_r | e \cdot p | \psi_h \rangle \right|^2 \frac{2}{\pi \lambda^2} \times V(E_{i,j} - E_h, \hbar \omega, \gamma_\tau, \gamma_\sigma)$$

where $E_{i,j}$ is the energy difference between a given pair of subband minima, $E_h$ is the exciton binding energy, $\lambda$ is the exciton Bohr radius, which was determined using a variational energy minimisation approach\textsuperscript{25,26} and $V()$ is the Voigt profile, where $\gamma_\tau$ and $\gamma_\sigma$ are the lifetime and disorder broadening components.

IV. DISCUSSION

Simulated absorption spectra for the four structures are shown by the dashed lines in Figs. 1(a–d) at zero applied bias and also at the maximum of the applied biases, $V_{\text{max}}$. The simulated datasets were calculated based on the method described in Ref. 16 and the parameters listed in the appendix (Table II), together with the methodology described above, which were used to determine the lifetime broadening components of the exciton peaks as well as the indirect absorption. We find very good agreement in the wavelengths of the absorption peaks as well as the indirect absorption. We find very good agreement in the wavelengths of the absorption peaks as well as the indirect absorption. We find very good agreement in the wavelengths of the absorption peaks as well as the indirect absorption. We find very good agreement in the wavelengths of the absorption peaks as well as the indirect absorption. We find very good agreement in the wavelengths of the absorption peaks as well as the indirect absorption. We find very good agreement in the wavelengths of the absorption peaks as well as the indirect absorption. We find very good agreement in the wavelengths of the absorption peaks as well as the indirect absorption. We find very good agreement in the wavelengths of the absorption peaks as well as the indirect absorption.

The magnitude of the measured sub-band-gap absorption was larger than in the simulated data, especially in the smaller quantum wells. This may result from the effect of threading dislocations, which have been shown to cause sub-band-gap absorption in highly-strained heteroepitaxial systems with large defect densities.\textsuperscript{28}

There are two components of the excitonic broadening: one arising from structural disorder or inhomogeneities, and one arising from the finite lifetime of the $\Gamma$-valley states. When comparing to the simulated data it is not straightforward to separate the two, because the Voigt profile used to model the excitonic broadening is a convolution of a Gaussian with a Lorentzian, and so the sum of linewidth broadening components does not equal the resulting linewidth. Our approach to reproducing the measured broadening of the absorption edge was to determine the lifetime broadening contribution to the exciton linewidths using the calculated $\Gamma$-valley scattering lifetime, and then to adjust the disorder broadening component so that the resulting spectrum has the same lineshape as the measured spectra, giving the simulated datasets shown by the dashed lines in Fig. 1.

The broadening of the absorption edge in the four measured samples is characterised by the half-width at half-maximum (HWHM) and scattering lifetime data listed in Table I. The lifetime broadening reflects the $\Gamma$-valley scattering lifetime and, as expected, increased with increasing confinement energy. The disorder broadening component increased as the width of the quantum wells was reduced. Additionally, for the larger quantum wells, the disorder broadening component also increased at the larger applied biases. Disorder broadening resulting from fluctuations in the thickness of the quantum wells throughout the structure may be described according to\textsuperscript{29}

$$\frac{\gamma_\sigma^2}{2 \ln(2)} = \frac{2h^2 \xi^2}{\lambda^2} \left[ (E'_c \beta_c)^2 + 8E'_c E'_h + (E'_h \beta_h)^2 \right]$$

where $E'_c$ and $E'_h$ are the differential of the $\Gamma$-valley electron and heavy-hole confinement energies with respect to the well width, and $\beta_c$ and $\beta_h$ relate the electron and

<table>
<thead>
<tr>
<th>Well width (nm)</th>
<th>Calculated lifetime, $\tau_\tau$ (fs)</th>
<th>Calculated lifetime broadening, $\gamma_\tau$ (meV)</th>
<th>Inhomogeneous broadening, $\gamma_\sigma$, at 0V $\gamma_\sigma$, at $V_{\text{max}}$ (meV)</th>
</tr>
</thead>
<tbody>
<tr>
<td>7</td>
<td>29.6</td>
<td>11.1</td>
<td>17</td>
</tr>
<tr>
<td>8</td>
<td>33.6</td>
<td>9.8</td>
<td>15</td>
</tr>
<tr>
<td>9</td>
<td>36.2</td>
<td>9.1</td>
<td>11</td>
</tr>
<tr>
<td>14</td>
<td>47.0</td>
<td>7.0</td>
<td>7</td>
</tr>
</tbody>
</table>

TABLE I. The calculated $\Gamma$-valley lifetime and associated HWHM of the hh$_1\Gamma_1$ exciton, as well as the disorder broadening components required to reproduce the measured data.
hole in-plane effective masses as follows:

\[
\beta_e = \frac{m_e + m_h}{m_h}, \quad \beta_h = \frac{m_h + m_e}{m_e}.
\]

The terms \( h \) and \( \xi \) are the height and correlation length of the interface disorder. Figure 4 shows the disorder broadening parameters for \( V = 0 \) listed in Table I, together with HWHM extracted from equation 8 using the simulated values for \( E'_v \), \( E'_e \), and \( \lambda \). It can be seen that the disorder broadening extracted from the experimental data follows the expected form given by equation 8 and, furthermore, that the fit obtained with \( h\xi = 2.4 \text{nm}^2 \) provides a measure of the interface roughness in these samples.

In order to gain more insight into how strain affects the \( \Gamma \)-valley lifetime in Ge/SiGe quantum well systems, the intervalley scattering lifetimes are shown as a function of energy in Fig. 5 for Ge fractions in the virtual substrate of 78\%, 90\%, and 95\% (i.e., those substrate compositions where the QCSE has been demonstrated). As expected, for a given substrate composition, a larger \( \Gamma \)-valley energy (corresponding to a smaller quantum well) results in more rapid scattering. At a given energy the \( \Gamma \)-valley lifetime is longest with the Si substrate where there is less compressive strain. Furthermore, the effect is most pronounced in the region around 800–900 meV, which is the range where the QCSE has been demonstrated in Ge/SiGe MQW systems. This results from the large strain-induced splitting between the \( \Delta_2 \) and \( \Delta_4 \) conduction band valleys, which affects the energy at which \( \Gamma \rightarrow \Delta \) scattering becomes allowed. Moreover, because of the hydrostatic strain shift of the \( \Gamma \)-valley band gap, for a given confinement energy the value of \( E - E_v \) will be smaller for a virtual substrate with a larger Ge fraction. These two considerations imply that the \( \Gamma \)-valley lifetime will be maximised by choosing a larger Ge fraction in the virtual substrate, which will result in structures with less indirect absorption and less lifetime broadening of the excitonic peaks. The two available measured values for the \( \Gamma \)-valley lifetime in these systems are indicated in Fig. 5. The calculations described here give rates for \( W_{\Gamma \rightarrow \Delta} \) that are almost twice as fast as have been reported experimentally. However, it should be pointed out that these experimental systems are limited in the temporal resolution owing to the finite duration of the optical pump pulses, and furthermore rely on optical bleaching (saturation), which has implications for final state blocking effects in the scattering processes. Consequently, it is possible that these measurements may over-estimate the \( \Gamma \)-valley lifetime, and so it is not entirely surprising that the calculated lifetimes reported here are shorter.

V. CONCLUSION

We have measured absorption spectra and observed the QCSE in Ge/SiGe MQW structures grown on Si\(_{0.22}\)Ge\(_{0.78}\) virtual substrates, where the dimensions of the quantum wells were systematically varied. The large compressive strain in Ge quantum wells results in a significant blue shift of the absorption edge compared with structures that were grown on virtual substrates with larger Ge fractions. Additionally, a broadening of the exciton peaks is observed, as well as an increase in the magnitude of the indirect absorption.

We calculated the intervalley phonon scattering rates in Ge/SiGe MQW systems in order to determine the \( \Gamma \)-valley lifetime. Two methods were compared: one ac-
counting for the quantum confinement of the electron wavefunctions and one assuming bulk-like wavefunctions. Good agreement was found between the two approaches, indicating that the details of the quantum confined wavefunctions are unimportant for scattering, and that the rates are primarily determined by the density of final states.

Indirect absorption in unstrained bulk Ge results from $\Gamma \rightarrow L$ intervalley phonon scattering, because scattering into the $\Delta$-valleys is not energetically allowed. However, in strain-balanced Ge/SiGe MQW stacks, the combined effects of the in-plane compressive strain and the confinement energy of the $\Gamma$-valley electrons means that $\Gamma \rightarrow \Delta$ scattering can occur, resulting in a decrease in the $\Gamma$-valley electron lifetime compared with bulk unstrained Ge. We find that $\Gamma \rightarrow \Delta$ scattering is an important contribution to the $\Gamma$-valley lifetime, and the calculated lifetimes in these highly-strained Ge/SiGe quantum wells were found to be less than 50 fs.

Although technological issues resulting in threading dislocations and interface roughness appear likely to affect the exciton linewidths, the results of our calculations imply that reducing the compressive strain in the Ge quantum wells by choosing a virtual substrate composition with a large Ge fraction will increase the $\Gamma$-valley lifetime because of the effects of intervalley phonon scattering. This will reduce the indirect absorption and lifetime broadening of the excitonic peaks, leading to an improvement in the performance that can be achieved in an EAM based on Ge/SiGe quantum wells. While the performance at 1.3 $\mu$m can be improved by reducing the sources of inhomogeneous broadening via improved growth, this is also the case for structures operating at longer wavelengths, and our work indicates that the wavelength-dependent performance of Ge/SiGe modulators will remain in place.

Appendix A: Material parameters

Table II lists the material parameters used to generate the simulated data: $\gamma_1$, $\gamma_2$ and $\gamma_3$, are the Luttinger parameters used to calculate the valence band structure; $\Delta_{SO}$ is the spin-orbit splitting; $a_{\text{lat}}$ is the lattice constant; $m^L$ is the $\Gamma$-valley electron effective mass, $m^f$ and $m^a$ is the longitudinal effective masses in the $L$- and $\Delta$-valleys, respectively, and $m^L$ and $m^a$ are the transverse effective masses; $E^L$, $E^\Delta$ and $E^\Gamma$ are the unstrained band gaps; $a^L$, $a^f$ and $a^\Delta$ are the hydrostatic band gap deformation potentials, and $b$ and $b^\Delta$ are the shear band gap deformation potentials (owing to the symmetry of the system there is no splitting of the $L$-valleys in response to biaxial in-plane strain); $D_{\Gamma\Delta}$ and $D_{\Delta L}$ are the intervalley phonon scattering deformation potentials and $\omega_{\Gamma L}$ and $\omega_{\Gamma\Delta}$ are the phonon angular frequencies. Where applicable, linear interpolation was used to determine the material parameters of the SiGe alloy layers, except for the lattice constant, where a bowing parameter of 0.026 nm was used.$^{30}$ A nonparabolicity parameter of 0.3 eV$^{-1}$ was used to determine the final density of states in the scattering rate calculations.$^{31}$

### Table II. The material parameters used in the calculations.

<table>
<thead>
<tr>
<th>Quantity</th>
<th>$\text{Si}$</th>
<th>$\text{Ge}$</th>
</tr>
</thead>
<tbody>
<tr>
<td>$\gamma_1$</td>
<td>4.22$^a$</td>
<td>13.4$^a$</td>
</tr>
<tr>
<td>$\gamma_2$</td>
<td>0.39$^a$</td>
<td>4.25$^a$</td>
</tr>
<tr>
<td>$\gamma_3$</td>
<td>1.44$^a$</td>
<td>5.69$^a$</td>
</tr>
<tr>
<td>$\Delta_{SO}$ (eV)</td>
<td>0.044$^a$</td>
<td>0.296$^a$</td>
</tr>
<tr>
<td>$a_{\text{lat}}$ (nm)</td>
<td>0.5431$^a$</td>
<td>0.5657$^a$</td>
</tr>
<tr>
<td>$m^L$</td>
<td>0.156$^b$</td>
<td>0.042$^c$</td>
</tr>
<tr>
<td>$m^f$</td>
<td>1.7$^d$</td>
<td>1.64$^e$</td>
</tr>
<tr>
<td>$m^a$</td>
<td>0.91$^f$</td>
<td>1.353$^g$</td>
</tr>
<tr>
<td>$m^L$</td>
<td>0.12$^h$</td>
<td>0.08$^i$</td>
</tr>
<tr>
<td>$m^a$</td>
<td>0.19$^j$</td>
<td>0.288$^k$</td>
</tr>
<tr>
<td>$E^\Gamma$ (eV)</td>
<td>4.2$^l$</td>
<td>0.8$^m$</td>
</tr>
<tr>
<td>$E^L$ (eV)</td>
<td>2.0$^n$</td>
<td>0.66$^o$</td>
</tr>
<tr>
<td>$E^\Delta$ (eV)</td>
<td>1.2$^p$</td>
<td>0.85$^q$</td>
</tr>
<tr>
<td>$a^L$ (eV)</td>
<td>-11.39$^r$</td>
<td>-8.97$^s$</td>
</tr>
<tr>
<td>$a^f$ (eV)</td>
<td>-3.12$^t$</td>
<td>-2.78$^u$</td>
</tr>
<tr>
<td>$a^\Delta$ (eV)</td>
<td>1.72$^v$</td>
<td>1.31$^w$</td>
</tr>
<tr>
<td>$b$ (eV)</td>
<td>-2.1$^x$</td>
<td>-2.86$^y$</td>
</tr>
<tr>
<td>$b^\Delta$ (eV)</td>
<td>9.61$^z$</td>
<td>9.42$^{</td>
</tr>
<tr>
<td>$D_{\Gamma\Delta}$ (eV/cm)</td>
<td>-</td>
<td>$2.5 \times 10^{8}$</td>
</tr>
<tr>
<td>$D_{\Delta L}$ (eV/cm)</td>
<td>-</td>
<td>$4.0 \times 10^{8}$</td>
</tr>
<tr>
<td>$\omega_{\Gamma L}$ (THz)</td>
<td>-</td>
<td>$6.54 \times 2\pi$</td>
</tr>
<tr>
<td>$\omega_{\Gamma\Delta}$ (THz)</td>
<td>-</td>
<td>$7.61 \times 2\pi$</td>
</tr>
</tbody>
</table>

$^a$ Data from Ref. 32
$^b$ Data from Ref. 33
$^c$ Data from Ref. 34
$^d$ Data from Ref. 35
$^e$ Data from Ref. 36
$^f$ Data from Ref. 37
$^g$ Data from Ref. 31
$^h$ Data from Ref. 38
$^i$ Data from Ref. 39
$^j$ Data from Ref. 40
$^k$ Data from Ref. 41
$^l$ Data from Ref. 42
$^m$ Data from Ref. 43
$^n$ Data from Ref. 44
$^o$ Data from Ref. 21